

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Reissue Application Of: Shunichi SATO

For: METHODS FOR GROWING SEMICONDUCTORS
AND DEVICES THEREOF FROM THE ALLOY
SEMICONDUCTOR GAINNAS

Reissue Application No.: Continuation of Reissue Application S.N. 09/860,369

Reissue Application Filing Date: Concurrently herewith

Original Patent No.: 5,904,549

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Mail Stop Reissue
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to examination on the merits, please amend the above-identified continuation
reissue application as follows: